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To:	Examiner Heather Doty	From:	Timothy N. Trop
Company:	US Patent Office	Date:	April 11, 2006
Fax:	(571) 273-8300	Pages:	6 (including cover sheet)
Your Re:	10/807,836	Our Re:	ITL 1133US

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Applicant:	Leonel R. Arana et al.	§	Art Unit:	2813
Serial No.:	10/807,836	§	Examiner:	Heather Anne Doty
Filed:	March 24, 2004	§	Docket:	ITL.1133US P19113
For:	Microfabricated Hot Wire Vacuum Sensor	§	Assignee:	Intel Corporation

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

REPLY TO FINAL REJECTION

Sir:

In response to the final rejection mailed March 20, 2006, please amend the above-referenced patent application as follows:

Date of Deposit: April 11, 2006
I hereby certify that this document is being facsimile transmitted to the United States Patent and Trademark Office (Fax No. 571/273-8300) on the date indicated above.
Cynthia L. Hayden
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